

Requesting Access to the Service of the Nanostructuring Lab of the Max-Planck-Institute for Solid State Research

Information on Applicant:

Last Name:

First Name:

Status: Student Assistant Bachelor Stud. Master Stud. PhD Student
 Postdoc Senior Scientist Scientific Technician

Institution:

Address:

Department /Research Group:

Day-to-Day Supervisor:

Email Address:

Phone No.:

Language speaking: German English

Research Topic:

Information on the Needs

Short Description of Processing Project / Purpose/ Estimate about Extent and Duration :

Needs:	Optical Lithography	Service	Direct Access
	Focused Ion Beam Processing	Service	
	EDX Analysis	Service	
	Electron Beam Lithography	Service	Direct Access
	Scanning Electron Microscope Imaging	Service	Direct Access
	Wire Bonding	Service	

Lift-off / Wet Etching	Service	Direct Access
Vacuum Deposition	Service	Direct Access
Reactive Ion Etching	Service	
Atomic Layer Deposition	Service	
(Al,Ga)As MBE Growth	Service	
HF Wet Etching	Service	
Others:		

Sample Materials:

Date:

Signature of Applicant:

To be filled/confirmed by the Department Director / University Professor:

Name of Director /Professor:

I agree with this application.

Remark:

Date:

Signature:

To be filled/confirmed by the MPI_FKF Managing Director:

Using the NSL Infrastructure requires a (restricted) IT-Account at the Institute (Email Account, Access to NSL Server).

If not available, the respective IT account should be granted.

The direct access to the NSL facilities is generally limited to half year. On request, further extensions are possible.

Direct access should be limited to (< half year).

Remark:

Date:

Signature of MPI-FKF Managing Director: